aperwork Reduction Act of 1995, no persons are required to respond to

PTO/SB/30 (10-01)
Approved for use through 10/31/2002. OMB 0651-003/f
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

REQUEST **FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL**

Address to: Commissioner for Patents Box RCE Washington, DC 20231

t displays a valid OMB control nu	ımber./
09/925,626	
August 10, 2001	#14
OKA, FUMIHITO	PO
2811	11
S. Hu	7
521.41463X00	12/1
	August 10, 2001 OKA, FUMIHITO 2811 S. Hu

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

Request for Continued Examination (RCE) practice under 37 CFR 1.114 does not apply to any utility or plant application filed prior to June 8, 1995, or to any design application. See Instruction Sheet for RCEs (not to be submitted to the USPTO) on page 2.

133	<u> </u>	to any design a	application. See instruction sheet for NCEs (not to be	Submitted to the	OSI TO/OII page 2	۲.		
1. Submission required under 37 C.F.R. § 1.114								
	a.	Previou	sly submitted			Ħ		
			nsider the amendment(s)/reply under 37 C.F.R. (y unentered amendment(s) referred to above will be entered).	§ 1.116 previo	usly filed onsly filed on	RECEIVED OCT -9 2007 CHNOLOGY CELLE		
		ii 🗌 Coi	nsider the arguments in the Appeal Brief or Repl	y Brief previou	sly filed on			
		iii 🔲 Oth	ner			夏丁西		
	b.	Enclose		_		DCT -9 2003 NOLOGY CENTER Pration		
		i 🔲 Am	endment/Reply iii.	Information [Disclosure Statem	ent (IDSE)		
		ii LAffi	davit(s)/Declaration(s) iv. $igtiiz$	Other Reque	st for Reconside	eration (FER 2800		
2.	Mic	coollongous		_		28(
۷.	2. Miscellaneous							
	 a Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of months. (Period of suspension shall not exceed 3 months; Fee under 37 C.F.R. § 1.17(i) required) 							
	b. Other							
3.	3. Fees The RCE fee under 37 C.F.R. § 1.17 (e) is required by 37 C.F.R. § 1.114 when RCE is filed.							
	a. The Director is hereby authorized to charge the following fees, or credit any overpayments, to							
			Account No. <u>01-2135</u>	10/08/2003 D	TESSEM1 00000078	09925626		
			E fee required under 37 C.F.R. § 1.17 (e)			770.00 OP		
	ii Extension of time fee (37 C.F.R. §§ 1.136 and 1.17) 01 FC:1801 7/0.00 UP							
		iii_ LJ Oth	ner					
	b. Check in the amount of \$ enclosed							
	C.		nt by credit card (Form PTO-2038 enclosed)					
			NG: Information on this form may become p					
be included on this form. Provide credit card information and authorization on PTO-2038.								
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT REQUIRED								
		Print/Type)	Alfred A. Stadnicki	Registration No	. (Attorney/Agent)	30,226		
Sign	atur	9		Date	October 6, 2003			
CERTIFICATE OF MAILING OR TRANSMISSION								
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner For Patents, Box RCE, Washington, DC 20231, or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below:								
		Print/Type)	Alfred A. Stadnicki					
Signature		9	122	Date	October 6, 2003	4.		
urder	Hou	r Statement Thi	s form is estimated to take 0.2 hours to complete. Time will y	any depending uny	on the people of the ind	lividual case. Any comments on		

the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND Fees and Completed Forms to the following address: Assistant Commissioner for Patents, Box RCE, Washington, DC 20231.

Docket No. 3008-0034 File No. 521.41463X00 Client No. PHCF-01103



IN THE UNITED STATES ATENT AND TRADEMARK OFFICE

In re Application of

Fumihito OKA

Group Art Unit: 2811

Application S/N: 09/925,626

: Examiner: S. Hu

Filed: August 10, 2001

For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE, CRYSTALLINE SILICON THIN FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

REQUEST FOR RECONSIDERATION

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

October 6, 2003

Sir:

This Request for Reconsideration is filed concurrently with a Request for

Continued Examination of the above-referenced application.

TECHNOLOGY CENTER 280